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Attorney Docket SEL 173

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Ohtani et al.)
Serial No.: 09/535,836)
Filed: March 28, 2000)
For: Semiconductor Device Having)
Multi-layer Wiring)
Art Unit: 2811)
Examiner: H. Vu)

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Shannon Wallace

Shannon Wallace 8/11/04
Signature Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT H (AFTER FINAL)

Sir:

In response to the Final Rejection Action dated May 14, 2003, please enter the following amendment in the above-identified application: